



AF/2800

PATENT
Attorney Docket No.: SAM-0298

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Jae-Hak Kim, et al.

Serial No.: 09/994,508

Filing Date: November 27, 2001

Title: METHOD OF FABRICATING SEMICONDUCTOR DEVICES HAVING LOW
DIELECTRIC INTERLAYER INSULATION LAYER

Examiner: Rao, S.

Group Art Unit: 2814

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12-6-02

Date

Amy Green
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Assistant Commissioner for Patents

Washington, D.C. 20231

TRANSMITTAL LETTER

Sir:

Enclosed herewith for filing in the above-identified patent application please find the following listed items:

1. Amendment Transmittal;
2. Amendment after Final Rejection in response to Office Action mailed on September 26, 2002; and
3. Return Postcard

In connection with the foregoing matter, please charge any additional fees which may be due, or credit any overpayment, to Deposit Account Number 50-1798. A duplicate copy of this letter is provided for this purpose.

Respectfully submitted,

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